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AUG 15 2006

PATENT APPLICATION
Attorney Docket: 10031180-1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Mirkarimi, et al
Serial No.: 10/692,772
Filed: 10/24/2003
For: Method for Etching Smooth
Sidewalls in III-V Based
Compounds for Electro-
Optical Devices
Group Art Unit: 1765

Examiner: Vinh, Lan

OK to enter

*LV
8/25/06*

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated 7/11/2006, in the above-identified patent application, Applicant submits the following Amendments and Remarks. Applicant respectfully requests that the following amendments be entered into the above-identified application and that the Examiner reconsider the grounds for rejection stated in the Office Action.